



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Jammy et al.

Examiner: M. Estrada

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Date: June 7, 2001

For: METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE

Assistant Commissioner for Patents
Washington, D.C. 20231
BOX AF

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RESPONSE UNDER 37 C.F.R. §1.116

Sir:

This is a Response to the Final Office Action mailed on April 10, 2001. Please consider the following amendments and remarks.

CERTIFICATE OF MAILING 37 C.F.R. §1.8(a)

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on June 7, 2001.

Dated: 6/7/01

Donald B. Paschburg
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